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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inter Patent Application of

Akira IZUMI

Date: September 28, 2005

Serial No.: 10/690,912

Group Art Unit: 1765

Filed: October 22, 2003

Examiner: Kin-Chan CHEN

For: SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING APPARATUS

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT
REMARKS/ARGUMENT

This Response is filed in reply to the Restriction Requirement mailed August 31, 2005. Applicant elects the invention of Group I, identified as claims 1-14 drawn to a method, classified in class 438, subclass 745.

Applicant reserves the right to file a divisional application directed to the subject matter covered in the non-elected claims.

Early and favorable consideration of the present application is earnestly solicited.

If this communication is filed after the statutory time period had elapsed and no separate Petition is enclosed, the Commissioner for Patents is petitioned, under 37 C.F.R. §1.136(a), to extend the time for filing a response to the outstanding Office Action by the number of months which will avoid abandonment under 37 C.F.R. §1.135. The fee under 37 C.F.R. § 1.17 should be charged to our Deposit Account No. 15-0700.

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on September 28, 2005

Max Moskowitz

Name of applicant, assignee or
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Signature

September 28, 2005

Date of Signature

Respectfully submitted,

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